



119/Response (119)
5/12/03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT

In re application of: Kapre, et al

Attorney Docket No.: 01-721/LS11P185

Application No.: 10/020,304

Examiner: Sefer, Ahmed N.

Filed: December 13, 2001

Group: 2826

**Title: BURIED CHANNEL DEVICES AND A
PROCESS FOR THEIR FABRICATION
SIMULTANEOUSLY WITH SURFACE
CHANNEL DEVICES TO PRODUCE
TRANSISTORS AND CAPACITORS WITH
MULTIPLE ELECTRICAL GATE OXIDES**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on May 12, 2003.

Signed:

Natalie Morgan

Natalie Morgan

Response to Final Office Action

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicants respectfully request reconsideration of the captioned application in view of the following remarks. A listing of the claims commences on page 2. Remarks and arguments begin on page 4 of this paper.

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